Manufacturers Suggested International Retail Price NT-MDT SPM accessories, Janyary 2012 (Cantilevers, Test samples, HOPG, SNOM probes)

NEW!!! Top Visual Non-contact silicon AFM probes - VIT_P series

each chip has 1 rectangular lever with inclined tip, typical curvature radius is 6 nm, no reflective coating resonant frequency 300 kHz / force constant 50 N/m

P/N	ITEM	PRICE, Euro
VIT_P/50	50 separated chips	1190
VIT_P/25	25 separated chips	666
VIT_P/15	15 separated chips	405

High Accuracy ETALON probes - HA_NC series, each chip has 2 rectangular polysilicon levers with sharp silicon tip (typical 10nm), Au reflective coating, resonant frequency 120/200 kHz / force constant 3.4 / 5.8N/m with typical dispersion ± 20%.

resonant frequency 120/200 kHz / force	constant 3.4 / 5.8N/m with typical dispersion ± 20%.	
P/N	ITEM	PRICE, Euro
		,
HA_NC/400	400 separated chips	3120
HA_NC/300	300 separated chips	2790
HA_NC/200	200 separated chips	2250
HA_NC/100	100 separated chips	1200
HA_NC/50	50 separated chips	750
HA_NC/15	15 separated chips	260

NONCONTACT "Golden" silicon cantilevers - NSG01, NSG10, NSG03, NSG30 series ,

each chip has 1 rectangular lever,
typical curvature radius is 6 nm. Au reflective coating *

typical curvature radius is 0 mm , Au lei		
P/N	ITEM	PRICE, Euro
NOOSAW NOOSAW		
NSG01W, NSG10W,		
NSG03W, NSG30W	Nonseparated wafer, minimum 410 chips	4080
NSG01/400, NSG10/400,		
NSG03/400, NSG30/400	400 separated chips	4420
NSG01/300, NSG10/300,		
NSG03/300, NSG30/300	300 separated chips	3570
NSG01/200, NSG10/200,		
NSG03/200, NSG30/200	200 separated chips	2550
NSG01/100, NSG10/100,		
NSG03/100, NSG30/100	100 separated chips	1360
NSG01/50, NSG10/50,		
NSG03/50, NSG30/50	50 separated chips	850
NSG01/15, NSG10/15,		
NSG03/15, NSG30/15	15 separated chips	300

Force Modulation "Golden" silicon cantilevers - FMG01 series, each chip includes 1 rectangular spring, typical curvature radius is 6 mm, Au reflective coating typical esonant frequency is 60kHz. typical force constant is 3Nm

typical esonant frequency is bukinz , typic		
P/N	ITEM	PRICE, Euro
FMG01W	Nonseparated wafer, minimum 410 chips	4080
FMG01/400	400 separated chips	4420
FMG01/300	300 separated chips	3570
FMG01/200	200 separated chips	2550
FMG01/100	100 separated chips	1360
FMG01/50	50 separated chips	850
FMG01/15	15 separated chips	300

CONTACT "Golden" silicon cantilevers - CSG10, CSG01, CSG30 series,

each chip includes **1 rectangular** spring, typical curvature radius is **6 nm** . Au reflective coating *****

typical calvatare radias is viiii , na refice	avo occarry	
P/N	ITEM	PRICE, Euro
CSG10W, CSG01W, CSG30W	Nonseparated wafer, minimum 410 chips	4080
CSG10/400, CSG01/400, CSG30/400	400 separated chips	4420
CSG10/300, CSG01/300, CSG30/300	300 separated chips	3570
CSG10/200, CSG01/200, CSG30/200	200 separated chips	2550
CSG10/100, CSG01/100, CSG30/100	100 separated chips	1360
	50 separated chips	850
CSG10/15, CSG01/15, CSG30/15	15 separated chips	300

f - for ordering cantilevers without reflective coating, please, add '/bare' after series name as it's in example: NSG01/bare/15 The price is the same as for cantilevers with Au reflective coating.

TIPLESS contact and noncontact "Golden" silicon cantilevers, CSG01, CSG10, CSG30, NSG01, NSG10, NSG03, NSG30, FMG01 series

P/N	ITEM	PRICE, Euro
CSG01/tipless, CSG10/tipless,	Nonseparated wafer, minimum 410 chips	4080
CSG30/tipless, NSG01/tipless,	400 separated chips	4420
NSG10/tipless, NSG03/tipless,	300 separated chips	3570
NSG30/tipless, FMG01/tipless	200 separated chips	2550

CONDUCTIVE contact and noncontact "Golden" silicon cantilevers, CSG01, CSG10, CSG30, NSG01, NSG10, NSG03, NSG30, FMG01 series

with **TiN, Au, Pt** conductive coatings, thickness of conductive coatings is 20

P/N	ITEM	PRICE, Euro
CSG10/Pt. TiN. Au.	Nonseparated wafer, minimum 410 chips	4560
CSG30/Pt.	400 separated chips	4940
NSG01/Pt.TiN. Au	300 separated chips	3990
NSG10/Pt, TiN, Au	200 separated chips	2850
NSG03/Pt. TiN. Au	100 separated chips	1520
NSG30/Pt, TiN, Au NSG30/Pt. TiN. Au	50 separated chips	950
FMG01/Pt, TiN, Au	15 separated chips	360

	Diffraction grating for submicron calibration SPM in the X or Y direction, period	
TDG01	278nm	200
SNG01	Test grating for Scanning Near field Optical Microscope	200
	Linear silicon gratings for Z calibration	
TGZ1	(height: TGZ1 - 19±1 nm)	100
	Linear silicon gratings for Z calibration	
TGZ2	(height: TGZ2 - 104±1,5 nm)	100
	Linear silicon gratings for Z calibration	
TGZ3	(height: TGZ3 - 540±2 nm)	100
	Linear silicon gratings for Z calibration	
TGZ4	(height: TGZ3 - 1317±8 nm)	100
TGG1	Silicon triangular grating	200
TGT1	Silicon tip grating	300
TGX1	Silicon square grating with negative angles	200
	Set of 3 linear silicon gratings for Z calibration	
TGS1	(3 different heights: TGZ1 - 19±1 nm, TGZ2 - 104±1,5nm, TGZ3 - 540±2 nm);	200
TGS2	Microscope grating set (TGG1, TGX1, TGT1, TGS1)	500
TGQ1	Silicon square grating for simultaneous calibration in X,Y and Z direction	300
TGSFull	Microscope grating set (TGG1, TGX1, TGT1, TGS1, TGQ1, TDG01)	850
STEPP	Silicon calibration sample with naturally step height 3,14nm.	100
	Test sample for calibrating AFM scanner movements along the Z axis with	
SiC/1.5	step height 1,5nm	120
	Test sample for calibrating AFM scanner movements along the Z axis with	
SiC/0,75	step height 0,75nm	120
PFM03	Test pattern for Piezoresponce Force Microscopy	350

(HOPG) Highly Oriented Pyrolytic Graphite / Size each 10x10 mm^2 Pieces with other sizes are available:

for ZYA and ZYB quality till 12x12mm^2, for ZYH quality till 30x30mm^2
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for ZYA and ZYB quality till 12x12mm^2, P/N	for ZYH quality till 30x30mm^2.	PRICE, Euro
Mosaic Spread: 0.4 +/- 0.1 degree (ZY/	A .	
Quality)		
ODAG# 5	Name in all their lands of F	107.5
GRAS/1,5 GRAS/1,2	Nominal thickness 1,5 Nominal thickness 1,2±0,2	137.5 106.25
Mosaic Spread: 0.8 +/- 0.2 degree (ZYI	8	
Quality)	Naminal Minimas 2.0	60.5
GRBS/2,0 GRBS/1,7	Nominal thickness 2,0 Nominal thickness 1,7±0,2	62.5 52.5
GRBS/1,2	Nominal thickness 1,2±0,2	37.5
GRBS/0,6	Nominal thickness 0,6±0,1	20
SNOM probes		
P/N	ITEM	PRICE, Euro
	SNOM probes (10 probes, aperture: less than 100nm, fiber diameter 125um,	
MEGOA	probe length 2m, probe tip coated by Al - 7-8mm, transmitted wavelength 400-	1100
MF001	550 nm). SNOM probes (10 probes, aperture: less than 100nm, fiber diameter 125um,	1190
	probe length 2m, probe tip coated by Al - 7-8mm, transmitted wavelength 450-	
MF002	600 nm). SNOM probes (10 probes, aperture: less than 100nm, fiber diameter 125um,	1190
	probe length 2m, probe tip coated by Al - 7-8mm, transmitted wavelength 600-	
MF003	770 nm).	1190
	SNOM probes (10 probes, aperture: less than 100nm, fiber diameter 125um,	
MF004	probe length 2m, probe tip coated by Al - 7-8mm, transmitted wavelength 780- 970 nm).	1190
	SNOM probes (10 probes, aperture: less than 100nm, fiber diameter 125um,	
MEGOS	probe length 2m, probe tip coated by Al - 7-8mm, transmitted wavelength 980-	1100
MF005	1600 nm). SNOM probes with glued quartz tuning-forks for Solver line systems with	1190
	measuring heads SNC100, SNC080, SNLG100, SNLG080 (10 probes,	
MF012	aperture: less than 100nm, fiber diameter 125 um, probe length 2m, probe tip coated by AI - 7-8mm, transmitted wavelength 450-600 nm).	2500
WIFU12	SNOM probes with glued quartz tuning-forks for Solver line systems with	2300
	measuring heads SNC100, SNC080, SNLG100, SNLG080 (10 probes,	
MF013	aperture: less than 100nm, fiber diameter 125um, probe length 2m, probe tip coated by AI - 7-8mm, transmitted wavelength 600-770 nm).	2500
III 010	SNOM probes with glued quartz tuning-forks for Solver line systems with	2000
	measuring heads SNC100, SNC080, SNLG100, SNLG080 (10 probes,	
MF014	aperture: less than 100nm, fiber diameter 125um, probe length 2m, probe tip coated by AI - 7-8mm, transmitted wavelength 780-970 nm).	2500
****	SNOM probes with glued quartz tuning-fork for NTEGRA line systems with	
	measuring head SNLG100NTF (10 probes, aperture: less than 100nm, fiber	
MF012_NTF	diameter 125um, probe length 2m, probe tip coated by Al - 7-8mm, transmitted wavelength 450-600 nm).	2500
_	SNOM probes with glued quartz tuning-forks for NTEGRA line systems	
	NTEGRA line systems with measuring head SNLG100NTF (10 probes, aperture: less than 100nm, fiber diameter 125um, probe length 2m, probe tip	
MF013_NTF	coated by Al - 7-8mm, transmitted wavelength 600-770nm).	2500
_	SNOM probes with glued quartz tuning-forks for NTEGRA line systems with	
	measuring head SNLG100NTF (10 probes, aperture: less than 100nm, fiber diameter 125um, probe length 2m, probe tip coated by Al - 7-8mm, transmitted	
MF014_NTF	wavelength 780-970 nm).	2500
	SNOM probes with glued quartz tuning-forks for NTEGRA line systems with	
	measuring head SNLG101NTF and Solver line systems with measuring head SNLG101 (10 probes, aperture: less than 100nm, fiber diameter 125um, probe	
	length 2m, probe tip coated by AI - 7-8mm, transmitted wavelength 400-550	
MF111_NTF	nm).	2500
	SNOM probes with glued quartz tuning-forks for NTEGRA line systems with measuring head SNLG101NTF and Solver line systems with measuring head	
	SNLG101 (10 probes, aperture: less than 100nm, fiber diameter 125um, probe	
MF112_NTF	length 2m, probe tip coated by Al - 7-8mm, transmitted wavelength 450-600 nm).	2500
1911 112_1311	SNOM probes with glued quartz tuning-forks for NTEGRA line systems with	2300
	measuring head SNLG101NTF and Solver line systems with measuring head	
	SNLG101 (10 probes, aperture: less than 100nm, fiber diameter 125um, probe length 2m, probe tip coated by Al - 7-8mm, transmitted wavelength 600-770	
MF113_NTF	nm).	2500
	SNOM probes with glued quartz tuning-forks for NTEGRA line systems with	
	measuring head SNLG101NTF and Solver line systems with measuring head SNLG101 (10 probes, aperture: less than 100nm, fiber diameter 125um, probe	
	length 2m, probe tip coated by AI - 7-8mm, transmitted wavelength 780-970	
MF114_NTF	nm). SNOM probes with glued quartz tuning-forks for NTEGRA line systems with	2500
	measuring head SNLG101NTF and Solver line systems with measuring head	
	SNLG101 (10 probes, aperture: less than 100nm, fiber diameter 125um, probe	
MF115_NTF	length 2m, probe tip coated by Al - 7-8mm, transmitted wavelength 980-1600 nm).	2500
WIFT19_NTF	inny.	2500
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Tuning forks for SNOM probes P/N	ITEM	PRICE, Euro
r*/N	II EWI	FRICE, EUIO
	Set of 10 tuning forks for Solver line systems with measuring heads SNC100,	†
TF001/10	SNC080, SNLG100, SNLG080.	1000
TE004 NTE/40	Set of 10 tuning forks for NTEGRA line systems with measuring head	10
TF001_NTF/10	SNLG100NTF.	1250
TF101_NTF/10	Set of 10 tuning forks for NTEGRA line systems with measuring head SNLG101NTF and Solver line systems with measuring head SNLG101.	1250
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antilever sets		
P/N	ITEM	PRICE, Euro
	AFM probe sets:	
	50 chips - for contact AFM;	
BIOSET-200	100 chips - for noncontact modes; 50 chips - contact AFM for liquid	3500
BIOSE 1-200	AFM probe sets:	3500
	50 chips - for contact AFM;	
	100 chips - for noncontact modes;	
	20 chips - for spreading resistance;	
	25 chips - for SKM/SCM;	
MSSET/200	5 chips - for MFM	3075
	AFM AFM probe sets: 50 chips - for contact AFM;	
	100 chips - for noncontact modes;	
	5 chips - for SRI/SKM/SCM;	
POLYSET/160	5 chips - for MFM	2475
	AFM probe sets:	
	50 chips - for contact AFM;	
DOL VOET/455	100 chips - for noncontact modes;	0.400
POLYSET/155	5 chips - for MFM AFM probe sets:	2400
	50 chips - for contact AFM;	
	100 chips - for noncontact modes;	
	20 chips - for spreading resistance;	
	20 chips - for SKM/SCM;	
	5 chips - for MFM;	
SEMISET/200	5 chips NSC05 "Whisker type" for deep trenches measurements	3400
	AFM probe sets:	
	10 chips - for contact AFM; 30 chips - noncontact modes;	
BIOSET - 50	10 chips - for contact AFM for liquid	1100
	AFM probe sets:	
	10 chips - for contact AFM;	
	25 chips - for noncontact modes;	
	5 chips - for spreading resistance;	
MOOFT/50	5 chips - for SKM/SCM;	4050
MSSET/50	5 chips - for MFM AFM probe sets:	1050
	10 chips - for contact AFM;	
	30 chips - for noncontact modes;	
	5 chips - for SRI/SKM/SCM;	
POLYSET/50	5 chips - for MFM	1050
	AFM probe sets:	
	10 chips - for contact AFM;	
POLYSET/45	30 chips - for noncontact modes; 5 chips - for MFM	950
POLYSEI/45	AFM probe sets:	950
	10 chips - for contact AFM;	
	20 chips - for noncontact modes;	
	5 chips - for spreading resistance;	
	5 chips - for SKM/SCM;	1
	5 chips - for MFM;	1
SEMISET/47	2 chips NSC05 "Whisker type" for deep trenches measurements	1210
HALF WAFERS		ļ
	N	
CSG10W CSG10/Pt/HW	Nonseparated wafer, minimum 410 chips	2420 2700
COGTO/FUHW	Nonseparated wafer, minimum 410 chips	2700
		
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